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Our File No. ILL02-023-DIV-US

Jonathan M. Blanchard, Ph.D.

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Chang Liu, et al.

Serial No. 10/670,585

Filing Date: September 25, 2003

For SCANNING PROBE MICROSCOPY PROBE
AND METHOD FOR SCANNING PROBE
CONTACT PRINTING

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) Examiner James J. Leybourne
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) Group Art Unit No. 2881
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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

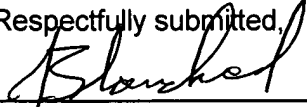
In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-1449 form, be made during the course of examination of the above-referenced application for United States Letters Patent.

These references were first cited in the International Search Report dated October 27, 2004 for corresponding PCT Patent Application No. PCT/US2004/015161. Under 37 C.F.R. § 97(c), the undersigned attorney states that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this statement. Accordingly, Applicant submits that no fee is required for this Supplemental Information Disclosure Statement.

This application is a divisional application of Serial No. 10/440,022. Accordingly, all information previously submitted to and/or cited by the Examiner is not provided, according to 37 C.F.R. § 1.98(d).


The Commissioner is hereby authorized to charge any fees associated with this communication, not covered by check or credit card payment or credit any overpayment to Deposit Account No. 50-3123. A duplicate copy of this sheet is attached.

Respectfully submitted,



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Form PTO-1449 (Rev. 8-88)	Attorney Docket No. ILL02-023-DIV-US	Serial No. 10/670,585
	Applicant: Chang Liu, et al.	
	Filing Date: September 25, 2003	Group: 2881

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

Examiner Initials*		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	B1	5,883,387	03/1999				
	B2	6,156,215	12/2000				

FOREIGN PATENT DOCUMENTS

Examiner Initials*		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	B3	EP 0786642	07/1997	EP				
	B4	WO99/56176	11/1999	WO				

OTHER ITEMS - NON PATENT LITERATURE DOCUMENTS

Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages

Examiner Initials*		
B5	Higa, K. et al., "Fabrication of Microcantilever with a Silicon Tip Prepared by Anodization", Japanese Journal of Applied Physics, vol. 37, no. 12B, pp. 7078-7080, (1998).	
B6	International Search Report for application no. PCT/US2004/015161 dated October 27, 2004.	

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.